

PI nano[™] Z, Scanner for SR-Microscopy

Low-Profile, Low-Cost, Nanopositioning System for Super Resolution Microscopy



PI nano™ Z nanopositioning stages (shown with optional slide and Petri dish holder) feature a very low profile of 20 mm (0.8"), a large aperture and deliver highly accurate motion with sub-nanometer resolution.

- Extremely Fast Step & Settle, From 5 msec
- Low Profile for Easy Integration: 20 mm (0.8")
- 100 and 200 µm Travel Ranges
- Longest Lifetime with Proprietary PICMA® Piezo Technology
- Cost Effective due to Low-Cost Piezoresistive Sensors
- Compatible w/ Leading Image Acquisition Software Packages
- Closed-Loop Control for High Repeatability and Accuracy
- 24 Bit USB Controller & Software Included

High-Speed, Low Profile, Optimized for Microscopy

The new PI nano™ Z low-profile piezo Z stages are optimized for very fast step and settle and easy integration into high-resolution microscope applications. They feature a very low profile of 0.8" (20 mm), a large aperture, and travel ranges of up to 200 μm with sub-nanometer closed-loop resolution—ideal for leading-edge microscopy and imaging applications.

Longest lifetime is guaranteed by the integrated ceramic-encapsulated PICMA® piezo actuators. Due to the significantly higher humidity resistance, the patented PICMA® design provides up to 10 times longer life than conventional piezo actuators (see latest test results at www.pi.ws/picma).

Cost Effective Design, High Performance

PI nano[®] series piezo positioning stages are designed to provide high performance at minimum

For highly-stable, closed cost. operation, piezoresistive sensors are applied directly to the moving structure and precisely measure the displacement of the stage platform. The very high sensitivity of these sensors provides optimum position stability and responsiveness as well as sub-nanometer resolution. A proprietary servo controller significantly improves the motion linearity compared to conventional piezoresistive sensor controllers.

Working Principle / Reliability

Flexures optimized with Finite Element Analysis (FEA) are employed to guide the PI nano® series stages. FEA techniques give the design the highest possible stiffness in, and perpendicular to, the direction of motion, and to minimize linear and angular runout. Flexures allow extremely high-precision motion, no matter how minute, as they are completely free of play and friction. The award-winning PICMA®

piezo drives are more robust than conventional piezo actuators, featuring superior lifetime and performance in both dynamic and static applications. Because guidance, actuators and sensors are all maintenance-free, these nanopositioning systems achieve outstanding levels of reliability.

Controller & Software Included

The PI nano™ Z stage comes complete with a powerful closed-loop controller. The integration of 24-bit converters represents more than 2 orders of magnitude improvement over the still widely used 16-bit converters. The controller features USB & RS-232 digital interfaces as well as a wide-band analog interface and is compatible with leading image acquisition software packages such as MetaMorph etc.

The piezo controller comes with Windows installation software. DLLs and LabVIEW drivers. The extensive command set is based on the hardware-independent General Command Set (GCS), common to all PI micro & nanopositioning systems. The GCS philosophy greatly reduces the programming effort when upgrading a system with a different PI controller as well as when working on complex multi-axis positioning tasks, such coarse/fine control with motorized long-travel stages.

Ordering Information

P-736.ZR1S

Piezo-Z Slide Scanner, 100μm with 65x93mm Aperture, PR Sensors, 24-bit Controller with USB, RS-232, and analog

P-736.ZR2S

Piezo-Z Slide Scanner, 200µm with 65x93mm Aperture, PR Sensors, 24-bit Controller with USB, RS-232, and analog

Application Examples

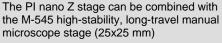
- Scanning microscopy
- 3D Imaging
- Laser technology
- Interferometry
- Metrology
- Biotechnology
- Micromanipulation















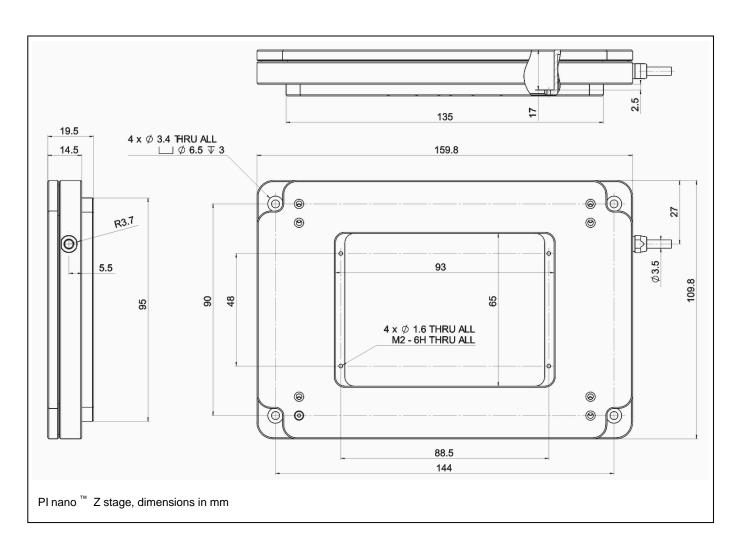


| Models | PI nano Z 100 | PI nano Z 200 | Units | Tolerance |
|-------------------------------------|----------------|----------------|-------|-----------|
| Active axes | Z | Z | | |
| Motion and positioning | | | | |
| Integrated sensor | Piezoresistive | Piezoresistive | | |
| Closed-loop travel | 100 | 200 | μm | |
| *Closed-loop / open-loop resolution | 0.2 / 0.4 | 0.4 / 0.7 | nm | typ. |
| Linearity | +/-0.1 | +/-0.1 | % | typ. |
| Repeatability | <4 | <5 | nm | typ. |
| Mechanical properties | | | | |
| Unloaded resonant frequency | 1000 | 700 | Hz | +/- 20% |
| Step Response, small signal | 5 | 7 | msec | +/- 20% |
| Max. payload | 500 | 500 | g | Max. |
| Drive properties | | | | |
| Ceramic type | PICMA® P-885 | PICMA® P-885 | | |
| Miscellaneous | | | | |
| Operating temperature range | 15 to 40 | 15 to 40 | °C | |
| Material | Aluminum | Aluminum | | |
| Weight | 550 | 550 | g | |
| Cable Length | 1.5 | 1.5 | m | |



A compact 24 bit piezo controller with USB, RS-232 and a high–bandwidth analog interface is included

*Resolution of PI Piezo Nanopositioners is not limited by friction or stiction. Value given is noise equivalent motion measured with interferometer.





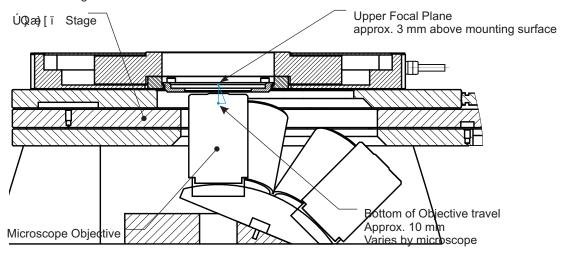
Optional High-Stability Manual Microscope Stage as Basis for Piezo Stage

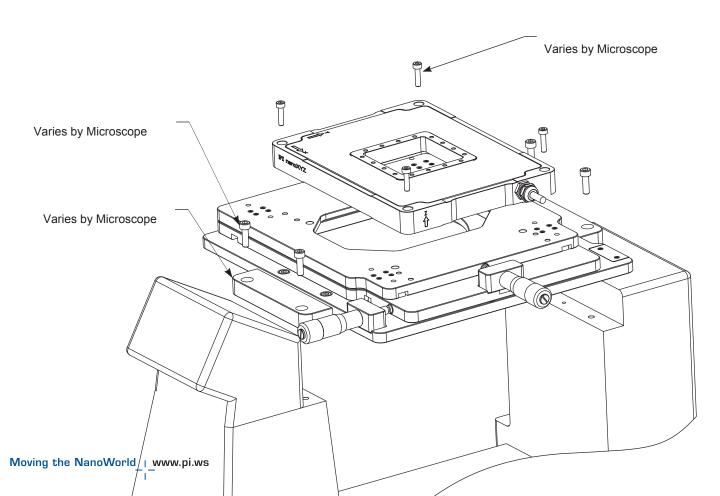
PI has designed the PQa) [i stage to be easily integrated to commercial microscopes through the use of the M-545 stage. M-545 stages are available for Nikon, Olympus, Zeiss and Leica inverted microscopes.

These stages mount directly to the microscope base and accept the UQæ [i as well as several other PI stages. The M-545 stages can be manually driven through micrometers or using PI's precision motorized actuators. Contact your PI sales representative for details.

When used in a microscope application, the focal plane for the microscope is located near the bottom of the stage. It is for this reason that the stage has a lower mounting surface. The figure below shows the nominal location of the focal plane. Vertical travel of the objective varies based on the microscope used.

A series of accessories is available from PI to assist with mounting a sample holder to the stage. The P-545.SH1 is available to hold standard 1"x 3" (25mm x 75mm) microscope slides and the P-545.PD1 is offered for holding 35mm Petri Dishes.





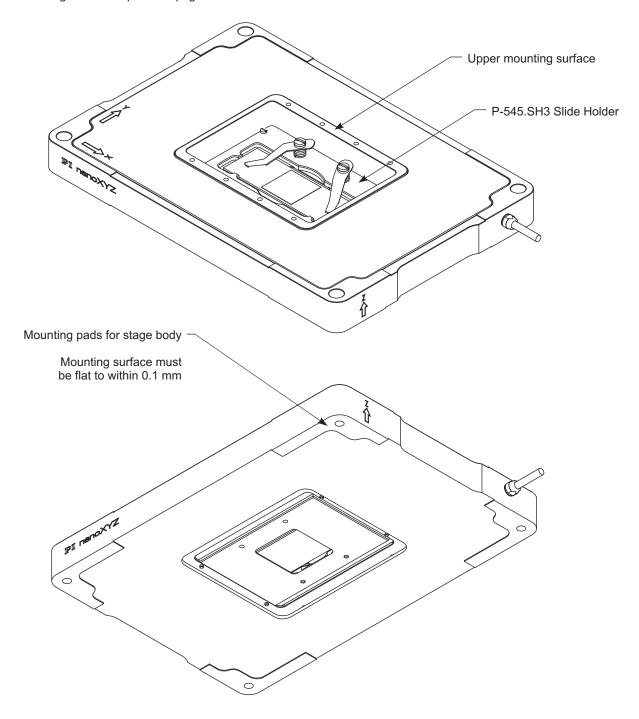


Mounting

 $PQ \Rightarrow [\ddot{i}]$ Stages have two mounting surfaces. The primary surface is on the top of the stage and protrudes from 0.5 mm from the body of the stage.

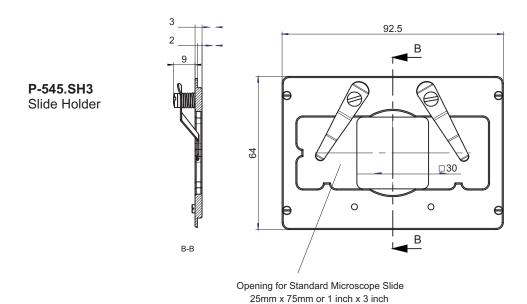
A secondary mounting surface is provided on the bottom of the stage. This surface allows mounting closer to the bottom surface of the stage body which can be useful in some applications, such as microscopy.

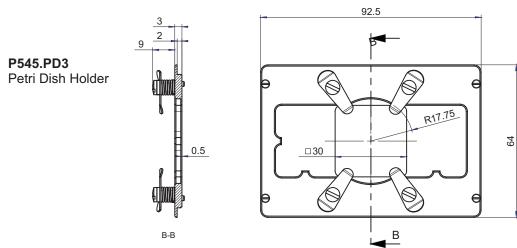
The planar dimensions and mounting hole pattern are identical. The applicable dimensions are shown in the diagram on the previous page.

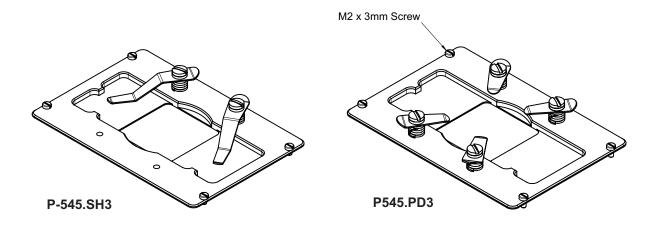




Sample Holder Accessories









P-545.PP3 Blank Plate

